

PATENT ASSIGNMENT

Electronic Version v1.1

Stylesheet Version v1.1

SUBMISSION TYPE:	NEW ASSIGNMENT								
NATURE OF CONVEYANCE:	ASSIGNMENT								
CONVEYING PARTY DATA									
<table border="1"><thead><tr><th>Name</th><th>Execution Date</th></tr></thead><tbody><tr><td>Cecile AULNETTE</td><td>02/12/2007</td></tr><tr><td>Christophe FIGUET</td><td>02/12/2007</td></tr><tr><td>Nicolas DAVAL</td><td>02/12/2007</td></tr></tbody></table>		Name	Execution Date	Cecile AULNETTE	02/12/2007	Christophe FIGUET	02/12/2007	Nicolas DAVAL	02/12/2007
Name	Execution Date								
Cecile AULNETTE	02/12/2007								
Christophe FIGUET	02/12/2007								
Nicolas DAVAL	02/12/2007								
RECEIVING PARTY DATA									
Name:	S.O.I.TEC SILICON ON INSULATOR TECHNOLOGIES S.A.								
Street Address:	Parc Technologique des Fontaines								
Internal Address:	Chemin des Franques								
City:	Bernin								
State/Country:	FRANCE								
Postal Code:	38190								
PROPERTY NUMBERS Total: 1									
<table border="1"><thead><tr><th>Property Type</th><th>Number</th></tr></thead><tbody><tr><td>Application Number:</td><td>11674392</td></tr></tbody></table>		Property Type	Number	Application Number:	11674392				
Property Type	Number								
Application Number:	11674392								
CORRESPONDENCE DATA									
Fax Number:	(212)294-4700								
<i>Correspondence will be sent via US Mail when the fax attempt is unsuccessful.</i>									
Phone:	2122946635								
Email:	dkumar@winston.com								
Correspondent Name:	WINSTON & STRAWN LLP - Allan A. Fanucci								
Address Line 1:	1700 K Street N.W.								
Address Line 4:	Washington, DISTRICT OF COLUMBIA 200063817								
ATTORNEY DOCKET NUMBER:	4717-22200								
NAME OF SUBMITTER:	ALLAN A. FANUCCI								
Total Attachments: 3 source=4717-22200-assignment#page1.tif									

CH \$40.00 11674392

500241450

PATENT
REEL: 019029 FRAME: 0099

source=4717-22200-assignment#page2.tif

source=4717-22200-assignment#page3.tif

ASSIGNMENT

WHEREAS, each of

Cécile AULNETTE, a citizen of France, residing
at 3, Place des Tilleuls, F-38000 Grenoble, France;

Christophe FIGUET, a citizen of France, residing at
438, rue Hector Berlioz 38920 Crolles, France; and

Nicolas DAVAL, a citizen of France, residing at
15, Bd Maréchal Leclerc 38000 Grenoble, France.

an ASSIGNOR, is an inventor of the invention in **METHOD OF MANUFACTURING A SEMICONDUCTOR HETEROSTRUCTURE** for which an application for a Patent of the United States, identified by Winston & Strawn LLP Docket No. **4717-22200**

☐ is executed on even date herewith.

☒ was filed on 02/13/2007 as Application No. 11/674,392.

WHEREAS, **S.O.I.TEC SILICON ON INSULATOR TECHNOLOGIES S.A.**, a French corporate body having a place of business at Parc Technologique des Fontaines, F-38190 Bernin, France, ASSIGNEE, is desirous of obtaining each inventor's entire right, title and interest in, to and under the said invention, the said application and corresponding applications worldwide.

NOW, THEREFORE, in exchange for good and valuable consideration to each inventor, the receipt and sufficiency of which is hereby acknowledged, each ASSIGNOR has sold, assigned, transferred and set over, and by these presents does hereby sell, assign, transfer and set over, unto the said ASSIGNEE, its successors, legal representatives and assigns, his or her entire right, title and interest in, to and under the invention, and any United States provisional or non-provisional application embodying the invention or any other United States application claiming priority to a provisional application under 35 U.S.C. § 119(e) or converted therefrom, or to any application claiming the benefit of a non-provisional application under 35 U.S.C. § 120, including all divisions, continuations, and continuations-in-part thereof, and all Patents of the United States which may be granted thereon and all reissues and extensions thereof;

And each ASSIGNOR hereby authorizes and requests the Commissioner of Patents and Trademarks of the United States, and any Official of any country or countries foreign to the United States, whose duty it is to issue patents or other evidence or forms of industrial property protection on applications as aforesaid, to issue the same to the ASSIGNEE, its successors, legal representatives and assigns, in accordance with the terms of this instrument;

And each ASSIGNOR hereby covenants and agrees that he or she has the full right to convey the entire interest herein assigned, and that he or she has not executed, and will not execute, any agreement in conflict herewith;

And each ASSIGNOR hereby further covenants and agrees that he or she will communicate to the ASSIGNEE, its successors, legal representatives and assigns, any facts known to him or her respecting said invention, testify in any legal proceeding, sign all lawful papers, execute all divisional, continuing, reissue and foreign applications, make all rightful oaths, and generally do everything possible to aid the ASSIGNEE or, its successors, legal representatives and assigns, to obtain and enforce proper protection for said invention in all countries;

And each ASSIGNOR hereby authorizes the ASSIGNEE's patent attorney to complete this form by the addition of the application number, application filing date, and attorney docket number, if necessary.

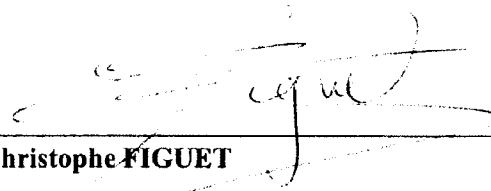
In witness whereof, each inventor has affixed his or her signature.

2007-02-12
Date Cécile AULNETTE

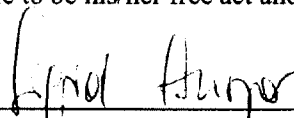
On this 12th day of February, 2007 before me appeared Cécile AULNETTE, to me known and known to me to be the person of that name, who signed the foregoing instrument, and acknowledged the same to be his/her free act and deed.

Arnd Hüper
Witness
SIGRID HUSZAR
ASSISTANT IP

Date 12 février 2007


Christophe FIGUET

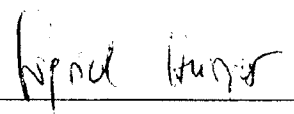
On this 12th day of February, 2007 before me appeared **Christophe FIGUET**, to me known and known to me to be the person of that name, who signed the foregoing instrument, and acknowledged the same to be his/her free act and deed.


Witness Assistant IP

Date 2007-02-12


Nicolas DAVAL

On this 12th day of February, 2007 before me appeared **Nicolas DAVAL**, to me known and known to me to be the person of that name, who signed the foregoing instrument, and acknowledged the same to be his/her free act and deed.


Witness Assistant IP